Abstract Submitted for the MAR13 Meeting of The American Physical Society

Piezoresponse force microscopy imaging of nanostructures created by conductive AFM lithography at oxide heterointerfac¹ MENGCHEN HUANG, FENG BI, University of Pittsburgh, SANGWOO RYU, CHANG-BEOM EOM, University of Wisconsin-Madison, JEREMY LEVY, University of Pittsburgh — Nanoscale control of the metal-insulator transition in 3-unit cell (u.c.) LaAlO₃/SrTiO₃ heterostructures using conductive AFM (c-AFM) lithography allows the creation of conductive nanostructures ². Piezoelectric effects have recently been observed in planar LaAlO₃/SrTiO₃ heterostructures ³, and the piezoresponse differs between the conducting and insulating states of 3-u.c. samples where c-AFM modulates the transition ⁴. We have employed piezoresponse force microscopy (PFM) to detect and image the piezoresponse variations of nanostructures created by c-AFM lithography. PFM imaging allows visualization of the nanostructures, expanding capabilities for characterizing and studying individual devices.

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